

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

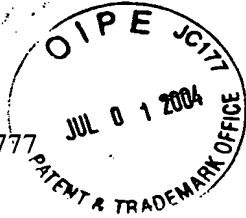
In re the Application of

Tsuyoshi KANEKO et al.

Application No.: 10/092,777

Filed: March 8, 2002

For: METHOD OF FABRICATING SURFACE-  
EMISSION TYPE LIGHT-EMITTING DEVICE,  
SURFACE-EMITTING SEMICONDUCTOR  
LASER, METHOD OF FABRICATING THE SAME,  
OPTICAL MODULE AND OPTICAL  
TRANSMISSION DEVICE



Group Art Unit: 2822

Examiner: M. Wilczewski

Docket No.: 112181

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

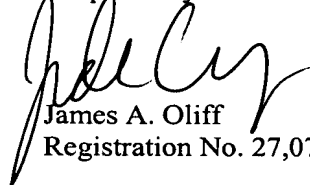
In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)  
continued examination.

☒ Applicants further request entry and consideration of the submission filed June 1, 2004.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper  
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 155738 in the amount of ☒ \$770.00 as payment of the fees  
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees  
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two  
duplicate copies of this page are enclosed.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

Jude L. Cooney  
Registration No. 54,045

07/02/2004 CNGUYEN 00000096 10092777

01 FC:1801

770.00 DP

JAO:JLC/aaw

Date: July 1, 2004

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;

Charge any fee due to our  
Deposit Account No. 15-0461